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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

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| INFORMATION DISCLOSURE STATEMENT | | Docket Number 10191/2162 | |
| Application Number 10/057,455 | Filing Date Jan. 24, 2002 | Examiner Roberts P. Culbert | Art Unit 1763 |

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|---|---|
| Title METHOD OF MANUFACTURING A MICROMECHANICAL COMPONENT | Applicant(s) Frank FISCHER et al. |
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MICHELLE M. CARNIAUX

1. In accordance with the duty of disclosure **KENYON & KENYON** 56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicant(s) hereby bring the following reference(s) to the attention of the Examiner. The reference(s) are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated on the modified PTO form 1449.
3. The Commissioner is hereby authorized to charge payment of the 37 C.F.R. §1.17(p) (submission of an Information Disclosure Statement under §1.97(c)) fee of **\$180.00** and any additional fees that may be required to the deposit account of **Kenyon & Kenyon**, deposit account number **11-0600**. A duplicate copy of this communication is enclosed for charging purposes.

Dated: 20 April 2004

By:

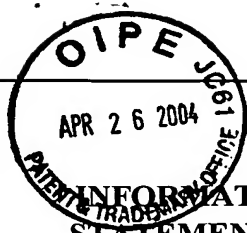
[Signature]
Richard L. Mayer (Reg. No. 22,490)

04/27/2004 AADDF01 00000009 110600 10057455

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANTS
PTO FORM 1449**

ATTY. DOCKET NO.
10191/2162

SERIAL NO.
10/057,455

APPLICANT(s)

Frank FISCHER et al.

FILING DATE
Jan. 24, 2002

GROUP
1763

U. S. PATENT DOCUMENTS

| EXAMINER INITIAL | PATENT NUMBER | PATENT DATE | NAME | CLASS | SUBCLASS | FILING DATE |
|---------------------|------------------|----------------|------------|-------|----------|----------------|
| | 5,985,164 | Nov. 16, 1999 | Chu et al. | | | |
| | | | | | | |
| | | | | | | |

FOREIGN PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUB- CLASS | TRANSLATION | |
|---------------------|--------------------|----------------|---------|-------|---------------|-------------|----|
| | | | | | | YES | NO |
| | 199 39 318 | Feb. 22, 2001 | Germany | | | X* | |
| | 0 867 702 | Sept. 30, 1998 | Europe | | | N/A | |
| | | | | | | | |
| | | | | | | | |

* English Abstract provided.

OTHER DOCUMENTS

| EXAMINER INITIAL | AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC. |
|---------------------|--|
| | B. Li, et al., "Germanium as a Versatile Material for Low-Temperature Micromachining", Journal of Microelectromechanical Systems, IEEE Inc. New York, Vol. 8, No. 4, December 1999, pgs. 366-372 |
| | |
| | |

| EXAMINER | DATE CONSIDERED |
|---|-----------------|
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |